



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Daniel Stearns et al.

Attorney Docket: CIL-10843

Serial No. : 09/896,722

Art Unit: 1765

Filed : June 29, 2001

Examiner: R. Kunemund

For : A Method To Repair Localized Amplitude  
Defects In A EUV Lithography Mask Blank

PETITION FOR EXTENSION OF TIME UNDER 37 CFR 1.136(a)

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

This is a request under the provisions of 37 CFR 1.136(a) to extend the period for filing a reply in the above identified application.

The requested extension fee for a three month extension (37 CFR 1.17(a)(3) is \$950.

The Commissioner is hereby authorized to charge this fee (\$950) to Deposit Account Number 501913.

If any impediments remain, please contact the undersigned at 808-875-0012.

Respectfully submitted,

  
John P. Wooldridge  
Attorney for Applicant  
Registration No. 38,725

10/04/2004 ZJUHAR1 00000019 501913 09896722  
02 FC:1253 950.00 DA

Dated: September 27, 2004